



NEW ATTORNEY DOCKET NO.: 052640-5031-01

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	
)	Confirmation No. 5216
Namwoong PAIK et al.)	
)	Group Art Unit: 1753
Application No.: 10/695,485)	
)	Examiner: Unassigned
Filed: October 29, 2003)	
)	
For: METHOD OF FORMING NON-OXIDE)	
THIN FILMS USING NEGATIVE)	
SPUTTER ION BEAM SOURCE)	

Commissioner for Patents
U.S. Patent and Trademark Office
2011 South Clark Place
Customer Window, MS Non-Fee Amendment
Crystal Plaza Two, Lobby, Room 1B03
Arlington, VA 22202

Sir:

PRELIMINARY AMENDMENT

Prior to the examination on the merits of the above-identified application, please amend the above-identified application as follows: